

Message Text

CONFIDENTIAL

PAGE 01 PARIS 18272 212122Z
ACTION EB-07

INFO OCT-01 EUR-12 ISO-00 DODE-00 NSAE-00 USIA-06
TRSE-00 ERDA-05 CIAE-00 COME-00 /031 W
-----032793 212123Z /73

P 212131Z JUN 77

FM AMEMBASSY PARIS

TO SECSTATE WASHDC PRIORITY 4520

C O N F I D E N T I A L PARIS 18272

USOECD

EXCON

E.O. 11652: XGDS1

TAGS: ESTC, COCOM

SUBJ: US POWER SEMICONDUCTOR MANUFACTURING FACILITY TO
POLAND - IL 1355

REF: COCOM DOC. (77) 309

USDEL HAS GRANTED ONE WEEK EXTENSION TO JUNE 27 FOR GER-
MAN VIEWS ON REFCASE. UKDEL HAVING LIFTED HIS RESERVE
JUNE 9 CASE NOW PENDING ONLY GERMAN FINAL POSITION.
SALZMAN

CONFIDENTIAL

NNN

Message Attributes

Automatic Decaptioning: X
Capture Date: 01-Jan-1994 12:00:00 am
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: POLICIES, SEMICONDUCTOR DEVICES, STRATEGIC TRADE CONTROLS, EXPORT LICENSES, IL 1355
Control Number: n/a
Copy: SINGLE
Sent Date: 21-Jun-1977 12:00:00 am
Decaption Date: 01-Jan-1960 12:00:00 am
Decaption Note:
Disposition Action: RELEASED
Disposition Approved on Date:
Disposition Case Number: n/a
Disposition Comment: 25 YEAR REVIEW
Disposition Date: 22 May 2009
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1977PARIS18272
Document Source: CORE
Document Unique ID: 00
Drafter: n/a
Enclosure: n/a
Executive Order: X1
Errors: N/A
Expiration:
Film Number: D770221-1062
Format: TEL
From: PARIS USOECD
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1977/newtext/t19770635/aaaaberp.tel
Line Count: 38
Litigation Code IDs:
Litigation Codes:
Litigation History:
Locator: TEXT ON-LINE, ON MICROFILM
Message ID: 91486479-c288-dd11-92da-001cc4696bcc
Office: ACTION EB
Original Classification: CONFIDENTIAL
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 1
Previous Channel Indicators: n/a
Previous Classification: CONFIDENTIAL
Previous Handling Restrictions: n/a
Reference: n/a
Retention: 0
Review Action: RELEASED, APPROVED
Review Content Flags:
Review Date: 02-Mar-2005 12:00:00 am
Review Event:
Review Exemptions: n/a
Review Media Identifier:
Review Release Date: n/a
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
SAS ID: 2082460
Secure: OPEN
Status: NATIVE
Subject: US POWER SEMICONDUCTOR MANUFACTURING FACILITY TO POLAND - IL 1355
TAGS: ESTC, US, PL, COCOM
To: STATE
Type: TE
vdkgvwkey: odb://SAS/SAS.dbo.SAS_Docs/91486479-c288-dd11-92da-001cc4696bcc
Review Markings:
Margaret P. Grafeld
Declassified/Released
US Department of State
EO Systematic Review
22 May 2009
Markings: Margaret P. Grafeld Declassified/Released US Department of State EO Systematic Review 22 May 2009